



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Richard M. WASSERMAN et al.

Application No.: 10/719,210

Filed: November 24, 2003

Docket No.: 116523

For: SYSTEMS AND METHODS FOR RAPIDLY AUTOMATICALLY FOCUSING A
MACHINE VISION INSPECTION SYSTEM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

Respectfully submitted,

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Date: December 17, 2003

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Sheet 1 of 1

US Dept. of Commerce PATENT & TRADEMARK OFFICE			ATTY DOCKET NO. 116523	APPLICATION NO. 10/719,210		
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			APPLICANT(S) Richard M. WASSERMAN et al.			
			FILING DATE November 24, 2003			
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)						
	1	QVPAK 3D CNC Vision Measuring Machine Users Guide, published January 2003.				
	2	QVPAK 3D CNC Vision Measuring Machine Operation Guide, published September 1996.				
EXAMINER				DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						